

Assistant Commissioner for Patents, Washington,
D.C. 20231, on December 7, 1998

Signature

Name of applicant, assignee or Registered Representative

CASE NO. 7103/30

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Homayoun Talieh et al.

Serial No.: 08/853,323

Filed: May 8, 1997

**For: LINEAR POLISHER AND
METHOD FOR
SEMICONDUCTOR WAFER
PLANARIZATION**

Examiner: G. Nguyen

Group Art Unit: 3723

RESPONSE AND AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Office action dated August 5, 1998 please enter the following amendment and consider the following remarks:

IN THE CLAIMS:

Please cancel claims 23 – 31 without prejudice.

Please amend claims 32, 34, 36-38, and 40 as follows:

RECEIVED
DEC 15 1998
Group 3700